The

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 5731

Akihisa HONGO et al.

Docket No. 2001_0133A

Serial No. 09/762,582

Group Art Unit 1753

Filed April 12, 2001

Examiner Brian Mutschler

SUBSTRATE PLATING METHOD AND APPARATUS

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of June 2, 2004, please amend the above-identified U.S. Patent application as follows: